



P/1071-1599

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Confirmation No.: 1535

Shigeki FUKUNAGA

Date: October 20, 2005

Serial No.: 10/647,007

Group Art Unit: 3729

Filed: August 22, 2003

Examiner: Carl J. Arbes

For: PARTS MOUNTING METHOD AND PARTS MOUNTING APPARATUS

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of a search report issued by a patent searching authority other than the PTO and the cited art together with a form listing the same for the convenience of the Examiner.

EXPRESS MAIL CERTIFICATE

I hereby certify that this correspondence is being deposited with the United States Postal Service as Express Mail to Addressee EV 324 436 076 US in an envelope addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on October 20, 2005:

Cheryl Desvignes

Name of Person Mailing Correspondence

Cheryl Desvignes

Signature

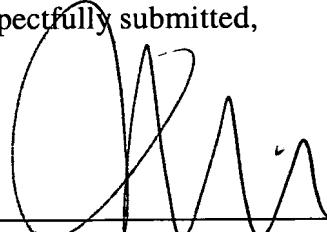
October 20, 2005

Date of Signature

JAF:lf

Enclosures

Respectfully submitted,


James A. Finder

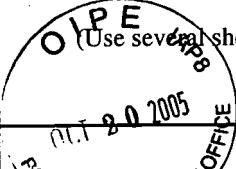
Registration No.: 30,173

OSTROLENK, FABER, GERB & SOFFEN, LLP

1180 Avenue of the Americas

New York, New York 10036-8403

Telephone: (212) 382-0700

APPLICANT'S ART CITATION  (Use several sheets if necessary)		Application 10/647,007		OFGS File No. P/1071-1599		
		Applicant Shigeki FUKUNAGA				
		Filing Date August 22, 2003		Group Art Unit 3729		
		U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)				
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	
	US-5,177,528	01-1993	Koromegawa et al.			
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					
FOREIGN PATENT DOCUMENTS						
Document Number	Date MM-YYYY	Country	Class	Translation		
				Sub-class	Yes	No
11-138367A	05-1999	JAPAN		<input checked="" type="checkbox"/> X		
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
		Chinese Office Action issued June 10, 2005 with English language translation and Japanese translation				
Examiner		Date Considered				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.						